

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2393	PRIORITY SERIAL NO. <del>09/592 604</del> <b>10/659,596</b>	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Fernando Gonzalez		
				PRIORITY FILING DATE June 12, 2000	PRIORITY GROUP 2818	

  

U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
TL	AA	6,251,754	Kobayashi et al.				
	AB	6,245,161	Henley et al.				
	AC	5,374,581	Ichikawa et al.				
	AD	4,891,329	Reisman et al.				
	AE	6,150,031	Yonehara				
	AF	6,083,324	Henley et al.				
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						

  

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AN						
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AS		
	AT		

  

EXAMINER <i>[Signature]</i>	DATE CONSIDERED <i>7/22/04</i>
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Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
M122-2393PRIORITY SERIAL NO.  
09/392,604LIST OF ART CITED BY APPLICANT  
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Fernando GonzalezPRIORITY FILING DATE  
June 12, 2000PRIORITY GROUP  
2818

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TL	AA	5,298,449	03/94	Kikuchi			
	AB	5,374,564	12/94	Bruei			
	AC	5,855,693	01/99	Murari et al.			
	AD	5,877,070	03/99	Goesele et al.			
	AE	5,882,987	03/99	Srikrishnan			
	AF	5,894,152	04/99	Jaso et al.			
	AG	5,953,622	09/99	Lee et al.			
	AH	6,004,406	12/99	Kobayashi et al.			
	AI	6,309,945 B1	10/01	Sato et al.			
	AJ	6,429,070 B1	08/02	Gonzalez et al.			
	AK	6,384,439 B1	05/02	Walker			
		6,423,992 B2	07/02	Fukuda, et al.			
	AL	5,998,847	12/99	Assaderaghi, et al.			

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

TL	AR		Gösele, U. et al., "Semiconductor Wafer Bonding: Science, Technology, and Applications", Electrochemical Society Proceedings
			Vol. 97-36, (©1998), pp. 400-425, 436-445.
	AS		

EXAMINER

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